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METHOD AND APPARATUS FOR GENERATING  
A PULSE OF VERY NARROW WIDTH

TECHNICAL FIELD OF THE INVENTION

This invention relates in general to high-frequency circuits and, more particularly, to high-frequency circuits which utilize a pulse with a very narrow width.

BACKGROUND OF THE INVENTION

In high-frequency circuits, there is often a need for a pulse having a very narrow width. As one example, there are low-noise, phase-locked microwave oscillators which effect phase sampling with a solid-state phase detector. In a known system, the sampling phase detector uses a step recovery diode (SRD) to generate a pulse which has a fairly narrow width, and which is used to clock a diode bridge mixer-phase detector. In particular, the voltage across the SRD is differentiated, in order to generate a pulse that corresponds to a time interval when the SRD voltage has a fairly high slew rate. Although circuits of this type have been generally adequate for their intended purposes, they have not been satisfactory in all respects.

More specifically, the narrow pulses generated by differentiating an SRD voltage have a width of approximately 22 to 50 picoseconds. While this is sufficiently narrow for many systems, there are other systems which operate at very high frequencies, where even this narrow pulse width is too large, and can produce undesirable effects such as jitter, and/or limits on the gain-bandwidth product.

SUMMARY OF THE INVENTION

From the foregoing, it may be appreciated that a need has arisen for a method and apparatus which avoid at least some of the disadvantages of pre-existing techniques. According to one form of the invention, a method and apparatus are provided to address this need, and involve: providing a circuit having a first portion which includes a resonant tunneling device, and a second portion which includes a differentiator; applying to the first portion an input signal; causing the resonant tunneling device to respond to the input signal by effecting a quantum jump in magnitude of an electrical signal characteristic from a first value to a second value, the second value being substantially different from the first value, and the quantum jump in magnitude from the first value to the second value taking an interval of time; and causing the differentiator to respond to the quantum jump of the electrical signal characteristic from the first value to the second value by producing a narrow pulse having a duration which is approximately equal to the interval of time.

A different form of the invention involves: providing a circuit having a first portion which includes a resonant tunneling device, and a second portion which includes a sampling portion with a sampling input; applying to the first portion an input signal; applying to the sampling input a signal to be sampled; causing the resonant tunneling device to respond to the input signal by effecting a quantum jump in magnitude of an electrical signal characteristic from a first value to a second value, the second value being substantially different from the first value, and the quantum jump in magnitude

from the first value to the second value taking an interval of time; and causing the sampling portion to respond to the quantum jump in magnitude of the electrical signal characteristic from the first value to 5 the second value by sampling the signal at the sampling input during a time period which is approximately equal in duration to the interval of time.

BRIEF DESCRIPTION OF THE DRAWINGS

A better understanding of the present invention will be realized from the detailed description which follows, taken in conjunction with the accompanying drawings, in which:

FIGURE 1 is a schematic circuit diagram of an apparatus which is a sampling phase detector circuit that embodies aspects of the present invention;

FIGURE 2 is a graph of a curve that shows how a current flowing through a resonant tunneling diode in the embodiment of FIGURE 1 will vary in response to variation of a voltage applied across it;

FIGURE 3 depicts two related graphs, the upper graph showing how the voltage across the resonant tunneling diode will vary over time as the current through it is progressively increased and then progressively decreased, and the lower graph showing an output voltage that a differentiating portion of the circuit of FIGURE 1 will produce over time in response to the voltage shown in the upper graph;

FIGURE 4 is a schematic circuit diagram of an apparatus which is an alternative embodiment of the apparatus of FIGURE 1, and which embodies aspects of the present invention;

FIGURE 5 is a schematic circuit diagram of an apparatus which is another alternative embodiment of the apparatus of FIGURE 1, and which embodies aspects of the present invention;

FIGURE 6 is a graph which depicts a power spectral density in relation to frequency of an output of a resonant tunneling diode in the embodiment of FIGURE 5;

FIGURE 7 is a schematic circuit diagram of an apparatus which is still another alternative embodiment of the apparatus of FIGURE 1, and which embodies aspects of the present invention; and

5 FIGURE 8 is a schematic circuit diagram of an apparatus which is yet another alternative embodiment of the apparatus of FIGURE 1, and which embodies aspects of the present invention.

DETAILED DESCRIPTION

FIGURE 1 is a schematic diagram of an apparatus which is a sampling phase detector circuit 10. The circuit 10 includes an input portion 12, a differentiating portion 13, and a sampling portion 14. 5 The circuit 10 has a reference input defined by a pair of terminals 16 and 17 in the input portion 12, a sample input defined by a pair of terminals 18 and 19 in the sampling portion 14, and an output defined by a pair of terminals 21 and 22 in the sampling portion 14. 10

The input portion 12 includes a transformer 26 with an input coil 27 and an output coil 28. The ends of the input coil 27 are each coupled to a respective one of the input terminals 16 and 17, and the input terminal 17 is also coupled to ground. 15 The input portion 12 includes a resonant tunneling diode (RTD) 31 of a known type, which is coupled between two nodes 32 and 33 of the circuit. The ends of the output coil 28 of the transformer 26 are each coupled to a respective one of the two nodes 32 and 33. The input portion 12 also includes a resistor 36 and a capacitor 37, which are coupled in parallel between the node 32 and ground, and a resistor 38 and a capacitor 39, which are coupled in parallel between the node 33 and ground. 20 The resistors 36 and 38 are substantially equivalent, and the capacitors 37 and 39 are substantially equivalent. 25

The differentiating portion 13 has two capacitors 46 and 47, which are substantially equivalent, and which effectively serve as a differentiator. The capacitor 46 has one end coupled to the node 32, and its opposite end coupled to a node 48. The capacitor 47 has one end

coupled to the node 33, and its opposite end coupled to a node 49.

The sampling portion 14 includes two Schottky diodes 51 and 52, which are equivalent. The diodes 51 and 52 are coupled in series between the nodes 48 and 49, and a further node 56 is defined between the diodes 51 and 52. The diodes 51 and 52 are oriented so that the cathode of diode 51 is coupled to the node 48, and the anode of diode 52 is coupled to the node 49. The sampling portion 10 14 has three resistors 61-63 which are coupled in series with each other between the nodes 48 and 49. The resistors 61 and 63 have substantially the same resistance. The resistor 62 is a variable trim resistor, with a slider coupled to the terminal 22 of the output. 15 The resistor 62 can be adjusted so as to maintain balance within the illustrated circuit.

In the sampling portion 14, the terminal 18 of the sample input is coupled to ground. A capacitor 71 is coupled between the node 56 and the terminal 19 of the sample input. A resistor 72 is coupled between the node 20 56 and the terminal 21 of the output, and a capacitor 73 is coupled between the terminal 21 and ground.

The RTD 31 is a device of a known type, with operational characteristics which are known in the art. 25 Nevertheless, to facilitate an understanding of the present invention, the operational characteristics of the RTD 31 are discussed briefly here.

FIGURE 2 is a graph of a curve that shows how a current flowing through the RTD 31 will vary in response 30 to variation of a voltage applied across the RTD 31. It will be noted that the current has a resonant peak at 81, and has a further and larger resonant peak at 82, which

is not visible in its entirety in FIGURE 2. There is a valley 83 between the two peaks 81 and 82.

Although the curve in FIGURE 2 can be viewed as a representation of how current varies as a function of a variation in voltage, it can conversely be viewed as a representation of how voltage varies as a function of a variation in current. In this regard, it will be noted that, as the current through the RTD is progressively increased to a value of  $I_1$  from a value of zero, the voltage progressively increases to a value of  $V_1$  from a value of zero, as indicated diagrammatically at 86.

Then, as soon as the current exceeds  $I_1$  the voltage suddenly makes a quantum jump at 87 from a value of  $V_1$  at the top of the resonant peak 81 to a value of  $V_2$  at a point along the leading edge of the resonant peak 82. As is known in the art, this significant change in voltage from  $V_1$  to  $V_2$  occurs extremely rapidly, for example as fast as 1.5 to 2.0 picoseconds. Then, as the current continues to progressively increase above  $I_1$ , the voltage progressively increases above  $V_2$ , as indicated diagrammatically at 88.

Assume that the current is thereafter progressively decreased. The voltage also progressively decreases, as indicated diagrammatically at 91. The decreasing current eventually reaches a value of  $I_2$ , which corresponds to a voltage  $V_3$ . As soon as the current is decreased below the value  $I_2$ , then the voltage very rapidly makes a quantum jump at 92 from the voltage  $V_3$  to the voltage  $V_4$ , and then continues to progressively decrease, as indicated at 93. The change at 92 from the voltage  $V_3$  to the voltage  $V_4$  occurs very rapidly, for example in about 1.5 to 2.0 picoseconds. The time intervals of 1.5 to 2.0

picoseconds mentioned above are typical time intervals, but both are determined by the structural configuration of the RTD, and either or both can be varied by adjusting the structural configuration of the RTD.

5       The curve shown in FIGURE 2 represents a relationship between a positive current and a positive voltage for the RTD 31. For a negative current and negative voltage, and as is known in the art, there is a similar curve for the RTD 31, which is a mirror image of  
10      the curve shown in FIGURE 2, reflected about the origin point at the intersection of the two axes.

15      During normal operation, a reference voltage  $V_{REF}$  is applied between the input terminals 16 and 17. For purposes of the present discussion, this input signal is assumed to be a sine wave, but it could alternatively be some other type of waveform. The transformer 26 responds to this input signal by causing a current to flow through the RTD 31, where the variation in current flow through the RTD conforms to a sine function.

20      FIGURE 3 shows two related graphs. The upper graph shows an example of how the voltage across the RTD 31 varies over time, as the current through the RTD 31 is first progressively increased, and then progressively decreased. In this regard, the curve shown in FIGURE 3 has segments 106-108 and 111-113, which respectively correspond to 86-88 and 91-93 in FIGURE 2. For clarity in the present discussion, the curve segments 106, 108, 111 and 113 are assumed to correspond to portions of the sine wave where the rate of change is relatively constant, and they are therefore shown in FIGURE 3 as straight lines.

The curve segment 107 represents the rapid quantum jump in voltage from  $V_1$  to  $V_2$ , and the curve segment 112 represents the rapid quantum drop in voltage from  $V_3$  to  $V_4$ . As discussed above, it is an inherent characteristic 5 of the RTD 31 that the voltage changes at 107 and 112 each occur very rapidly, for example in about 1.5 to 2.0 picoseconds. The voltage across the RTD 31, such as that shown in the upper graph in FIGURE 3, serves as the input to the differentiating portion 13 in the circuit of 10 FIGURE 1, which includes the capacitors 46 and 47.

The lower graph in FIGURE 3 shows the output voltage that the differentiating portion 13 will produce over time between the nodes 48 and 49, in response to the voltage shown in the upper graph in FIGURE 3. In effect, 15 the curve shown in the lower graph of FIGURE 3 represents the derivative of the curve shown in the upper graph of FIGURE 3. It will be noted that the rapid voltage change at 107 in the upper graph produces a large positive pulse 121 of very narrow width, and the voltage change at 112 produces a large negative pulse 122 of very narrow width. 20 In the disclosed embodiment, the widths 123 and 124 of the pulses 121 and 122 are each in the range of approximately 1.5 to 2.0 picoseconds, for example about 1.7 picoseconds. Due to the polarity of the diodes 51 and 52, the diodes recognize one of the pulses 121 and 122 and ignore the other thereof, such that only one of 25 these pulses actually appears at the node 56 which is located between the diodes 51 and 52.

A signal which is to be sampled is applied between 30 the terminals 18-19 of the sample input, and is referred to here as  $V_{SAMPLE}$ . This signal is an alternating current (AC) signal, and is applied to the storage capacitor 73

through the coupling capacitor 71 and the resistor 72. The voltage across the storage capacitor 73 determines the output voltage  $V_{OUT}$  at the output terminals 21-22. When the node 56 receives a large and narrow pulse from 5 the differentiating portion 13 through the diodes 51 and 52, the diodes 51 and 52 effectively couple in the load resistors 61-63, so that a portion of the energy introduced at the sample input 18-19 is absorbed in the load resistors 61-63. This deprives the storage 10 capacitor 73 of a portion of the charge that would otherwise end up on the capacitor 73. Consequently, the pulse from the differentiating portion 13 causes the output voltage  $V_{OUT}$  to be different than it otherwise would have been, which represents a form of sampling of 15 the sample signal  $V_{SAMPLE}$  during the time duration of the narrow pulse received from differentiating portion 13.

FIGURE 4 is a schematic diagram of an apparatus 140, which is an alternative embodiment of the apparatus 10 of FIGURE 1. The apparatus 140 includes an input portion 142 which is different from the input portion 12 of FIGURE 1, and also includes a differentiating portion 13 and a not-illustrated sampling portion which are respectively identical to the differentiating portion 13 and the sampling portion 14 of FIGURE 1. In FIGURES 1 20 and 4, equivalent parts are identified with the same reference numerals, and the following discussion 25 addresses the differences between these embodiments.

The input portion 142 in FIGURE 4 includes the input terminals 16 and 17 of the reference input, and also 30 includes the RTD 31. The input portion 142 has two terminals 146 and 147, to which are applied respective direct current (DC) bias voltages +V and -V, which are

equal and opposite in magnitude. A field effect transistor (FET) 148 has its source coupled to the terminal 146, and its drain coupled to one end of a resistor 149. The other end of the resistor 149 is coupled to the node 32 between the capacitor 46 and the RTD 31. The gate of the FET 148 is coupled to the node 32.

A further field effect transistor (FET) 151 has its source coupled to the node 33 between the capacitor 47 and RTD 31, and its drain coupled to one end of a resistor 152. The other end of the resistor 152 is coupled to the terminal 147. The gate of the FET is coupled to the terminal 16. In the embodiment of FIGURE 4, the FETs 148 and 151 are equivalent, and the resistors 149 and 152 have the same resistance. The FET 148 and resistor 149 effectively serve as a current source, and the FET 151 and the resistor 152 effectively serve as a current sink.

A reference signal is applied to the reference input terminals 16-17, in the form of a voltage which causes dynamic variation in the conductivity of the FET 151, thereby effecting dynamic variation of the amount of current flowing through the FET 148, the resistor 149, the RTD 31, the FET 151, and the resistor 152. Thus, the voltage at the terminals 16-17 is effectively converted into a varying current through the RTD 31, which causes the RTD 31 to produce a voltage between the nodes 32 and 33 which is similar to the voltage shown in the upper graph of FIGURE 3. The differentiating portion 13 and not-illustrated sampling portion of the embodiment of FIGURE 4 operate the same as their counterparts in the

embodiment of FIGURE 1, and are therefore not described here in detail.

FIGURE 5 is a schematic diagram of an apparatus 160 which is another alternative embodiment of the apparatus 5 10 of FIGURE 1. The apparatus 160 includes an input portion 162 which is different from the input portion 12 of FIGURE 1, and also includes a differentiating portion 13 and a not-illustrated sampling portion which are respectively identical to the differentiating portion 13 10 and the sampling portion 14 of FIGURE 1. In FIGURES 1 and 5, equivalent parts are identified with the same reference numerals, and the following discussion addresses the differences between these embodiments.

In the input portion 162 of FIGURE 5, the node 33 15 between the RTD 31 and the capacitor 47 is coupled to one end of a resistor 164, and the other end of the resistor 164 is coupled to ground. A resistor 166 has one end coupled to the node 32 between the capacitor 46 and the RTD 31, and its other end coupled to a node 167. The resistors 164 and 166 have the same resistance. The FET 151 20 has its source coupled to the terminal 146, its drain coupled to the node 167, and its gate coupled to the terminal 16. The terminal 17 is coupled to ground. A further FET 171 has its source coupled to the node 167, 25 its drain coupled to the terminal 147, and its gate coupled to its own drain. The FET 171 is equivalent to the FET 151. The FET 171 serves as a form of constant current source, which operates substantially independently of changes in the voltage applied across it. Since the current flowing through the FET 171 is 30 constant but the current flowing through the FET 151 is not, variation of the current through the FET 151

operates through the resistor 166 to vary the current flowing through the RTD 131.

As in the input portions of the other embodiments discussed above, the circuitry of the input portion 162 takes the voltage of the reference signal applied at the terminals 16-17 of the reference input, and converts it into a corresponding current flow through the RTD 31. This causes the RTD 31 to generate between the nodes 32 and 33 a voltage comparable to that shown in the upper graph of FIGURE 3. The differentiating portion 13 and the not-illustrated sampling portion of the embodiment 160 operate in the same manner as their counterparts in the embodiment of FIGURE 1, and their operation is therefore not described here in detail.

FIGURE 6 is a graph which depicts an operational characteristic of the circuit of FIGURE 5. In particular, FIGURE 6 shows the power spectral density of the output of the RTD 151 (vertical axis), in relation to frequency (horizontal axis). This characteristic is determined mathematically by multiplying the Fourier transform of the voltage across the RTD by its complex conjugate. The units along the X-axis represent frequency/200 MHz. The units along the Y-axis are dBc, or in other words Decibels relative to the power in the input carrier to the circuit. The curve of FIGURE 6 corresponds to application of a 10 GHz sine wave to the input of the FET 151. The two FETs 151 abd 171 serve as a non-inverting buffer of this signal, and the buffered output is applied to the resistor 166. The resistor 166 converts this voltage into a current, which is used as a sinusodial bias current to the RTD.

As evident from FIGURE 6, the effective output of the RTD is rich in harmonics, up to and above 200GHz. In particular, these harmonics are seen in the plot as strong, discrete peaks in the power spectral density at 5 various frequencies. Peaks are visible at the fundamental frequency (10 GHz), and at even and odd harmonics up to 190 GHz. Actually, the slow drop in spectral power with increasing frequency shows that the RTD waveform provides a very narrow pulse that will 10 approximate an ideal impulse generator, running at the frequency of the input (which in this example case is 10 GHz). The harmonics are desirable for certain applications, for example where a circuit of the type shown in FIGURE 5 is used as part of a low noise, phase-locked microwave oscillator. The harmonics permit phase 15 lock to be accurately and reliably achieved at frequencies which are multiples of the fundamental frequency.

FIGURE 7 is a schematic diagram of an apparatus 180, 20 which is still another alternative embodiment of the apparatus 10 of FIGURE 1. The apparatus 180 includes an input portion 182, which is different from the input portion 12 of FIGURE 1, and also includes a differentiating portion 13 and a not-illustrated sampling 25 portion, which are respectively identical to the differentiating portion 13 and the sampling portion 14 of FIGURE 1. IN FIGURES 1 and 7, equivalent parts are identified with the same reference numerals, and the following discussion addresses the differences between 30 these embodiments.

In the input portion 182 of FIGURE 7, a reference input defined by terminals 186 and 187 is provided in

place of the reference input terminals 16-17 of FIGURE 1. The reference input voltage  $V_{REF}$  is applied to the terminal 186, and its complement is applied to the terminal 187.

5 A resistor 191 has a first end coupled to the node 33 between the capacitor 47 and the RTD 31, and has its other end coupled to the terminal 187. An additional RTD 192 has one end coupled to the node 32 between the capacitor 46 and the RTD 31, and has its other end coupled to one end of a resistor 193. The other end of the resistor 193 is coupled to the terminal 186. A reference current source 196 is coupled between the node 32 and ground. The RTDs 31 and 192 are equivalent, and the resistors 191 and 193 are equivalent.

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15 Like the input portions of the other embodiments described above, the input portion 182 takes the reference input signal and converts it into a corresponding current flow through the RTD 31, so that the RTD 31 produces between the nodes 32-33 a voltage of 20 the type shown in the upper graph of FIGURE 3. The differentiating portion 13 and the not-illustrated sampling portion of the apparatus 180 operate in the same manner as their counterparts in the apparatus 10 of FIGURE 1, and their operation is therefore not discussed 25 here in detail.

FIGURE 8 is a schematic diagram of an apparatus 210, which is an alternative embodiment of the apparatus 10 of FIGURE 1. The apparatus 210 includes an input portion 212 which is different from the input portion 12 of FIGURE 1, and also includes a differentiating portion 13 and a not-illustrated sampling portion which are respectively identical to the differentiating portion 13

and the sampling portion 14 of FIGURE 1. In FIGURES 1 and 8, equivalent parts are identified with the same reference numerals, and the following discussion addresses the differences between these embodiments.

5       In the input portion 212, the input terminals 16-17 and the transformer 26 of FIGURE 1 have been replaced with a photodiode 216 and a light source 218. The photodiode 216 is a component of a known type, such as a PIN photodiode or a metal-semiconductor-metal (MSM) photodiode. The photodiode has its anode coupled to the node 32, and its cathode coupled to the node 33. The light source 218 is a periodic pulsed laser of a type known in the art, such as a mode-locked laser, or a fiber-ring laser. Alternatively, the light source 218 could be a continuous laser with a mechanical shutter, or some other device that produces a periodic optical signal. The light source 12 outputs a varying optical signal 221, which serves as a clock signal that varies in a periodic manner. The optical clock signal 221 causes the photodiode 216 to alternate between conducting and non-conducting states. When the photodiode is in its conducting state, it effectively creates an electrical short across the RTD 31, so that the voltage across the RTD 31 is very low or zero. When the photodiode switches to its non-conducting state, current from the bias arrangement will cause a current to develop through the RTD 31, and the voltage across the RTD 31 will undergo a quantum jump such as that shown at 87 in FIGURE 2. In other respects, the operation of the circuit of FIGURE 8 is generally similar to the operation of the circuit 10 of FIGURE 1, and is therefore not described here in further detail.

The present invention provides a number of advantages. One such advantage results from the generation of a pulse of very narrow width through use of a resonant tuning diode with a high slew rate, where the slew rate is on the order of about 3 picoseconds per volt. This is five to ten times faster than the slew rate of the step recovery diodes (SRDs) used in pre-existing systems. Therefore, when the voltage across the RTD is differentiated, the result is a pulse with a very narrow width, which can be as much as 1/35 of the width of the typical pulse produced in pre-existing systems using SRDs. The ability to generate a very narrow pulse is advantageous in a variety of applications. As one example, when used in the context of a very fast sampling phase detector for a low-noise phase-locked microwave oscillator, the narrow pulse provides more accurate sampling, along with a reduction in jitter and an increase in bandwidth, where the bandwidth can be as much as five to ten times better than in comparable pre-existing systems which utilize SRDs. By using an RTD to generate a narrow pulse, sampling can occur at frequencies of 100 GHz to 200 Ghz, which was not possible with the wider pulses generated in pre-existing systems using SRDs.

Although several selected embodiments have been illustrated and described in detail, it will be understood that various substitutions and alterations can be made without departing from the scope of the present invention. That is, the depicted circuits are merely exemplary, and it is possible to add, delete, and/or rearrange components, or to utilize different circuit configurations, while still realizing the present

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invention. Other substitutions and alterations are also possible without departing from the spirit and scope of the present invention, as defined by the following claims.

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